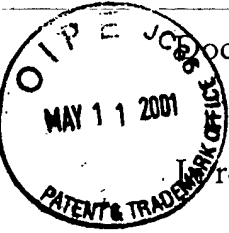


2872-46  
5/15/01



Application No.: YHK-039  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re Application of  
Ho Young CHOI et al.  
Serial No. 09/514,250  
Filed: February 28, 2000  
For: PROJECTION LENS SYSTEM

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Group Art Unit: 2872  
:  
Examiner: A. Chang  
:

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)(1)

Assistant Commissioner for Patents  
Washington, D. C. 20231

Sir:

Applicant petitions the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated February 9, 2001 for one (1) month from April 11, 2001 to May 11, 2001.

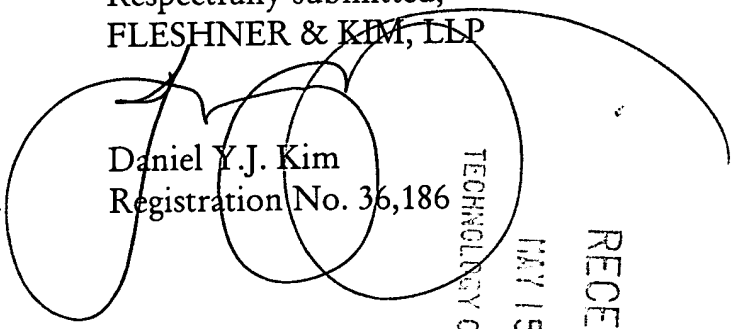
A check including the amount for the extension of time under 37 C.F.R. §1.17(a) is enclosed. Any deficiency or overpayment should be charged or credited to Deposit Account No. 16-0607.

05/14/2001 EEKUBAY1 00000123 09514250  
01 FC:115 110.00 DP

P.O. Box 221200  
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Date: May 11, 2001

Respectfully submitted,  
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